


Search Notes 	Application/Control No. 10750215	Applicant(s)/Patent Under Reexamination KIM ET AL.
	Examiner Zhu, Richard Z	Art Unit 2625

SEARCHED			
Class	Subclass	Date	Examiner
358	1.9, 1.18, 537	9/24/2007	RZ
715	517, 522, 523, 524, 525	9/24/2007	RZ
358	1.2	2/5/2008	RZ
715	274, 517	2/5/2008	RZ

SEARCH NOTES		
Search Notes	Date	Examiner
East database class and keyword limited search, see East search history	1/31/2007	RZ
Japanese Patent Office Application Search, base on IDS and East Prior Art Priority Chain	1/31/2007	RZ
Park Chan S consulted, Art Unit 2625 Class 358, Examiner	1/31/2007	RZ
Douglass Tran consulted, Art Unit 2625 Class 358, Primary Examiner	1/31/2007	RZ
King Poon consulted, Art Unit 2625 Class 358, Primary Examiner	1/31/2007	RZ
East database class and keyword limited search, see East search history	9/24/2007	RZ
East database class and keyword limited search, see East search history	2/5/2008	RZ

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner